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		Application Number	10/702,156
		Filing Date	November 5, 2003
		First Named Inventor	David L. Adler
		Art Unit	2881
		Examiner Name	<del>not yet known</del> A. Quas
		Attorney Docket Number	10011.001210 (P0980)

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
A.Z.	C	Sky Scalable High Performance Computers by SKYComputers, webpage [online]. Sky Computers, Inc. 2002, [retrieved on 11/04/2002]. Retrieved from the internet: <a href="http://www.skycomputers.com/hardware/hpc.html">http://www.skycomputers.com/hardware/hpc.html</a> .	
A.Z.	D	TROMP, R.M. "Low-energy electron microscopy", IBM J.RES. Develop, July 2000, pages 503-516, Vol. 44, No. 4, International Business Machines Corporation.	
A.Z.	E	CHANG, T.H. PHILIP, et al. "Multiple Electron-Beam Lithography", pages 1-26.	
A.Z.	F	DIEBOLD, ALAIN, et al. "Current State of Defect Review by Electron Beam Tools: A White Paper", January 14, 2000, pages 1-12, Technology Transfer#00013877 A-Eng., SEMATECH.	
A.Z.	G	TOBIN, KENNETH W. "Inspection in Semiconductor Manufacturing", pages 1-13 (K.W. Tobin submission for: V. Sankaran, C.M. Weber, K.W. Tobin "Inspection in Semiconductor Manufacturing", Webster's Encyclopedia of Electrical and Electronic Engineering, vol. 10, pp. 242-262, Wiley & Sons, NY, NY, 1999.	
A.Z.	H	RACEway Interlink Functional Specification, November 8, 2000, pgs 1-104, Mercury Computer Systems, Inc., Chemsford, MA.	

Examiner Signature	<u>A.Z.</u>	Date Considered	<u>4/20/05</u>
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